

Multitest introduces MEMS solution for pressure sensors

I-Micronews

The Multitest MEMS concept equips a standard test handler with a pressure contact cassette and combines it with the pressure generator. The MEMS solution benefits from over 30 years experience in device handling and temperature performance at Multitest. The dedicated components can now be perfectly aligned to meet the special requirements of pressure tests.

Multitest's MEMS solutions for pressure tests cover the entire range from 0.2 to 20 bars with up to five different pressure levels over a temperature range from -40° to $+135^{\circ}\text{C}$. The MEMS solutions support absolute pressure tests as well as relative pressure and leakage tests.

For more information about Multitest's MEMS solution, visit www.multitest.com/MEMS [1] .

About Multitest

Multitest (headquartered in Rosenheim, Germany) is one of the world's leading manufacturers of test equipment for semiconductors. Multitest markets test handlers, contactors, and ATE printed circuit boards under the brands Multitest, ECT Interface Products, and Harbor Electronics. Globally more than 700 employees serve our customers in offices and branches in North America, Singapore, Malaysia, the Philippines, Taiwan, China and Thailand.

[SOURCE](#) [2]

Source URL (retrieved on 02/01/2015 - 6:30pm):

<http://www.mdtmag.com/news/2010/06/multitest-introduces-mems-solution-pressure-sensors>

Links:

[1] <http://www.multitest.com/MEMS>

[2] <http://www.i-micronews.com/lectureArticle.asp?id=4974>